



01-03-02

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#12/Electron
1/21/03
V/SIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jiping Li, Peter G. Borden
Assignee: Boxer Cross Inc
Title: Evaluating Sidewall Coverage In A Semiconductor Wafer
Serial No.: 09/788,273 Filing Date: 2/16/2001
Examiner: Michelle Estrada Group Art Unit: 2823
Docket No.: BOX009 US

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated December 3, 2002 Applicants elect for further prosecution the first specie related to "a method comprising illuminating the wafer with a beam of electromagnetic radiation having a majority of energy polarized in a direction other than parallel to a longitudinal direction of the feature." Claims 1-11, 13-17, and 23-37 are believed to read on this first specie.

Attached is a copy of a power of attorney authorizing the undersigned to prosecute the above-identified application. Although it was filed on October 28, 2002, the above-identified Office Action was still addressed to the old address. Please address all future correspondence to: Silicon Valley Patent Group LLP, 2350 Mission College Blvd, Suite 360, Santa Clara, CA 95054 which is the address associated with our customer number 34036 If there are any questions, please call the undersigned at 408-982-8200, ext 3.

Via Express Mail Label No.

EU 789 864 432 US

Respectfully submitted,

S. Omkar

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Reg. No. 36,320

San Jose, California
December 30, 2002
RECEIVED
JAN - 6 2003
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